



WHAT IS CLAIMED IS:

1. A tilttable-body apparatus comprising:

- 5 a frame member;
- a tilttable body; and
- a pair of torsion springs having a twisting longitudinal axis, said torsion springs being disposed along the twisting longitudinal axis opposingly with said tilttable body being interposed, said torsion springs
- 10 supporting said tilttable body flexibly and rotatably about the twisting longitudinal axis relative to said frame member, said torsion springs including a plurality of planar portions, compliant directions of which intersect each other when viewed along a direction of the twisting longitudinal axis, and a center of gravity of said tilttable body being
- 15 positioned on the twisting longitudinal axis of said torsion springs.

2. The tilttable-body apparatus of claim 1, wherein said tilttable body is a planar tilttable body, and at least one of said planar portions of said torsion springs is slant to said planar tilttable body.

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3. The tilttable-body apparatus of claim 1, wherein a cross-sectional shape of said each torsion spring perpendicular to the twisting longitudinal axis is 90-degree or 180-degree rotationally symmetric, and said each torsion spring comprises a plurality of planar

25 portions.

4. The tilttable-body apparatus of claim 1, wherein said each

torsion spring comprises a plurality of separate planar portions, longitudinal axes of which are set parallel to each other, and compliant directions of which intersect each other when viewed along the direction of the twisting longitudinal axis.

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5. The tilttable-body apparatus of claim 1, wherein a cross-sectional shape of said each torsion spring perpendicular to the twisting longitudinal axis is symmetric with respect to a plane including the twisting longitudinal axis.

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6. The tilttable-body apparatus of claim 1, wherein said torsion springs are formed of a single crystal material.

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7. The tilttable-body apparatus of claim 6, wherein said torsion springs are formed of a single crystal silicon.

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8. The tilttable-body apparatus of claim 7, wherein said tilttable body is a planar tilttable body, at least one of said planar portions of said torsion springs has a surface slant to said planar tilttable body, and said slant surface is a (111) face of said single crystal silicon.

9. The tilttable-body apparatus of claim 1, wherein said frame member, said tilttable body, and said torsion springs are integrally formed from a substrate of a single crystal material.

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10. The tilttable-body apparatus of claim 9, wherein said single crystal material is a (100) single crystal silicon substrate, said torsion

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springs are formed by anisotropically etching said single crystal silicon substrate, said tilttable body is a planar tilttable body, at least one of said planar portions of said torsion springs has a surface slant to said planar tilttable body, and said slant surface is a (111) face of said single 5 crystal silicon substrate relative to said (100) substrate face.

11. The tilttable-body apparatus of claim 10, wherein a face relative to said (100) substrate face of a root portion of said each torsion spring, which connects to said frame member or said tilttable body, is a 10 (111) face of said single crystal silicon substrate.

12. The tilttable-body apparatus of claim 1, wherein said torsion springs are formed by performing deep etching, and said each torsion spring is defined by faces perpendicular to said frame member and faces parallel 15 to said frame member.

13. The tilttable-body apparatus of claim 1, wherein a cross section of said each torsion spring perpendicular to the twisting longitudinal axis has a shape of one of V, reversed-V, X, slash, broken-V, broken-reversed-V, 20 crisscross, broken-crisscross, H, broken-H, N, and angular S.

14. The tilttable-body apparatus of claim 1, wherein angles of said torsion springs are rounded by isotropic etching such that stress concentration on said angles of said torsion springs is reduced.

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15. The tilttable-body apparatus of claim 1, wherein cross sections of said torsion springs, which are disposed along the twisting longitudinal

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axis opposingly with said tilttable body being interposed, perpendicular to the twisting longitudinal axis are the same.

16. The tilttable-body apparatus of claim 1, wherein cross sections 5 of said torsion springs, which are disposed along the twisting longitudinal axis opposingly with said tilttable body being interposed, perpendicular to the twisting longitudinal axis are different from each other.

17. The tilttable-body apparatus of claim 16, wherein cross sections 10 of said torsion springs, which are disposed along the twisting longitudinal axis opposingly with said tilttable body being interposed, perpendicular to the twisting longitudinal axis are symmetric with each other with respect to a plane including the twisting longitudinal axis.

15 18. The tilttable-body apparatus of claim 1, wherein said tilttable body is a planar tilttable body, and cross sections of said torsion springs perpendicular to the twisting longitudinal axis are symmetric with each other with respect to a plane including the twisting longitudinal axis and parallel to said planar tilttable body.

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19. The tilttable-body apparatus of claim 4, wherein said each torsion spring comprises a plurality of separate planar torsion bars, and a cross section of said each torsion spring is symmetric with respect to a vertical line.

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20. The tilttable-body apparatus of claim 4, wherein said each torsion spring comprises a plurality of separate planar torsion bars, and

a cross section of said torsion spring is symmetric with respect to a horizontal line and a vertical line.

21. The tilttable-body apparatus of claim 1, wherein said frame
5 member includes an inner frame member and an outer frame member, said
tilttable body includes an inner tilttable body and an outer tilttable body
which is said inner frame member for supporting said inner tilttable body
through a pair of first torsion springs and is supported by said outer frame
member through a pair of second torsion springs, said inner tilttable body
10 is supported flexibly and rotatably about a first twisting longitudinal
axis of a pair of said first torsion springs, said outer tilttable body is
supported flexibly and rotatably about a second twisting longitudinal axis
of a pair of said second torsion springs, and pairs of said first and second
torsion springs are disposed along the first and second twisting
15 longitudinal axes opposingly with said inner and outer tilttable body being
interposed, respectively.

22. The tilttable-body apparatus of claim 21, wherein the first and
second twisting longitudinal axes extend forming an angle of 90 degrees.
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23. The tilttable-body apparatus of claim 1, further comprising
means for detecting a relative displacement between said frame member and
said tilttable body, and wherein the apparatus is constructed as a
mechanical-amount sensor.

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24. The tilttable-body apparatus of claim 1, further comprising
driving means for driving said tilttable body relative to said frame member,

and wherein the apparatus is constructed as an actuator.

25. The tilttable-body apparatus of claim 24, wherein said driving means comprises a stationary core, a coil wound on said stationary core,
5 and a moving core bonded to said tilttable body.

26. The tilttable-body apparatus of claim 1, further comprising driving means for driving said tilttable body relative to said frame member, and light deflecting means for deflecting a beam of light impinging on said
10 tilttable body, which is provided on said tilttable body, and wherein the apparatus is constructed as an optical deflector.

27. The tilttable-body apparatus of claim 26, wherein said driving means comprises a stationary core, a coil wound on said stationary core,
15 and a moving core bonded to said tilttable body.

28. The tilttable-body apparatus of claim 26, wherein said light deflecting means is one of a light reflective mirror and a diffraction grating.

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29. A tilttable-body apparatus comprising:
a frame member;
a planar tilttable body; and
a pair of torsion springs having a twisting longitudinal axis, said
25 torsion springs being disposed along the twisting longitudinal axis opposingly with said tilttable body being interposed, said torsion springs supporting said tilttable body flexibly and rotatably about the twisting

longitudinal axis relative to said frame member, said torsion springs including a plurality of planar portions, and at least one of said planar portions of said torsion springs being slant to said planar tilttable body.

5 30. A tilttable-body apparatus comprising:

 a frame member;
 a planar tilttable body; and

 a pair of torsion springs having a twisting longitudinal axis, said torsion springs being disposed along the twisting longitudinal axis

- 10 opposingly with said tilttable body being interposed, said torsion springs supporting said tilttable body flexibly and rotatably about the twisting longitudinal axis relative to said frame member, a cross-sectional shape of said each torsion spring perpendicular to the twisting longitudinal axis being 90-degree or 180-degree rotationally symmetric, said each torsion
15 spring including a plurality of planar portions, and compliant directions of said planar portions intersecting each other when viewed along a direction of the twisting longitudinal axis.

31. A tilttable-body apparatus comprising:

20 a frame member;
 a planar tilttable body; and

 a pair of torsion springs having a twisting longitudinal axis, said torsion springs being disposed along the twisting longitudinal axis opposingly with said tilttable body being interposed, said torsion springs

- 25 supporting said tilttable body flexibly and rotatably about the twisting longitudinal axis relative to said frame member, said each torsion spring including a plurality of separate planar portions, longitudinal axes of

which are set parallel to each other, and compliant directions of said separate planar portions intersecting each other when viewed along a direction of the twisting longitudinal axis

5 32. A scanning type display comprising:

- (a) a modulatable light source;
- (b) an optical deflector including:
 - a frame member;
 - a tiltable body; and

10 a pair of torsion springs having a twisting longitudinal axis, said torsion springs being disposed along the twisting longitudinal axis opposingly with said tiltable body being interposed, said torsion springs supporting said tiltable body flexibly and rotatably about the twisting longitudinal axis relative to said frame member, said torsion springs including a plurality of planar portions, compliant directions of which intersect each other when viewed along a direction of the twisting longitudinal axis, and a center of gravity of said tiltable body being positioned on the twisting longitudinal axis of said torsion springs;

15 driving means for driving said tiltable body relative to said frame member; and

20 light deflecting means for deflecting a beam of light impinging on said tiltable body from said light source, said light deflecting means being provided on said tiltable body;

25 (c) a picture display screen on which the beam of light from said deflecting means is projected; and

(d) control means for controlling modulation of said modulatable light source and operation of said tiltable body of said optical deflector

in an interlocking manner.

33. A method of fabricating a tilttable-body apparatus which includes a frame member formed of a (100) single crystal silicon substrate,
- 5 a tilttable body formed of the (100) single crystal silicon substrate, and a pair of torsion springs having a twisting longitudinal axis and formed of the (100) single crystal silicon substrate, the torsion springs being disposed along the twisting longitudinal axis opposingly with the tilttable body being interposed, the torsion springs supporting the tilttable body
- 10 flexibly and rotatably about the twisting longitudinal axis relative to the frame member, and the torsion springs including a plurality of planar portions defined by (100) and (111) faces of the single crystal silicon substrate, compliant directions of which intersect each other when viewed along a direction of the twisting longitudinal axis, said method comprising
- 15 the steps of:
- depositing mask layers on both upper and lower surfaces of the (100) single crystal silicon substrate, respectively;
 - patterning the mask layers in accordance with configurations of the tilttable body and the torsion springs; and
- 20 anisotropically etching the (100) single crystal silicon substrate using the patterned mask layers.

34. The method of claim 33, wherein said anisotropic etching is performed using an alkaline solution.

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35. The method of claim 33, further comprising a step of rounding angles of the torsion springs by isotropic etching such that stress

concentration on the angles of the torsion springs is reduced.

36. A method of fabricating a tilttable-body apparatus which includes a frame member formed of a planar substrate, a tilttable body formed of the planar substrate, and a pair of torsion springs having a twisting longitudinal axis and formed of the planar substrate, the torsion springs being disposed along the twisting longitudinal axis opposingly with the tilttable body being interposed, the torsion springs supporting the tilttable body flexibly and rotatably about the twisting longitudinal axis relative to the frame member, and the torsion springs including a plurality of planar portions defined by faces perpendicular to the planar substrate and faces parallel to the planar substrate, compliant directions of which intersect each other when viewed along a direction of the twisting longitudinal axis, said method comprising the steps of:

15 depositing mask layers on both upper and lower surfaces of the planar substrate, respectively;

patterning the mask layers in accordance with configurations of the tilttable body and the torsion springs;

20 performing a deep etching of the planar substrate from one surface of the planar substrate; and

performing a deep etching of the planar substrate from the other surface of the planar substrate.

37. The method of claim 36, wherein the planar substrate is a silicon substrate.